

In re U.S. Patent Application of

TSUCHIYA et al.

Art Unit 1773

Application Number: 10/750,882

Examiner Holly C. Rickman

Filed: January 5, 2004

For: METHOD FOR PRODUCING NANOPARTICLE LAYER HAVING UNIFORM EASY AXIS OF MAGNETIZATION, MAGNETIC RECORDING MEDIUM HAVING SUCH LAYER, ITS PRODUCTION METHOD, AND ITS PRODUCTION APPARATUS

Attorney Docket No. HITA.0482

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Final Office Action mailed on October 18, 2006, the period of response to which is set to expire on February 18, 2007, with the payment of the appropriate government extension fee for one month. Please amend the above-referenced application as follows:

ok to enter